



PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Makoto Sasaki et al.

Examiner: S. Hu

Serial No: 09/555,625

Art Unit: 2811

Filed: June 1, 2000

Docket: 13629

For: WIRING, TFT SUBSTRATE
USING THE SAME, MANUFACTURING
METHOD OF TFT SUBSTRATE, AND
LCD

Dated: October 24, 2001

46
Election
F. JONES
12-19-01
TECHNICAL STAFF

Assistant Commissioner for Patents
United States Patent and Trademark Office
Washington, D.C. 20231

RESPONSE UNDER 37 C.F.R. §§ 1.111, 1.142 AND 1.146

Sir:

In response to the Official Action dated September 25, 2001, applicants elect, for prosecution on the merits in the present application, the invention denoted in the outstanding Official Action as Invention I, constituting Claims 1-14 and 20, for prosecution on the merits in the present application. This election is made without traverse.

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on October 24, 2001.

Dated: October 24, 2001


Mishelle Mustafa